

10/768,568

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-2496		Priority SERIAL NO. 09/945,137		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Jerome Eldridge				
				Priority FILING DATE August 30, 2001		Priority GROUP 2822		
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
KBD ↓	AA	5,350,738	9/94	Hase et al				
	AB	5,272,341	12/93	Micheli et al				
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	AD	6,461,931	10/02	Eldridge				
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	AI	5,953,619	09/99	Miyazawa				
	AJ							
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		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
KBD ↓	AK	EP 0727832 A1	08/96	EPO/Miyashita et al				
	AL							
	AM							
	AN							
	AP							
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KBD ↓	AP		John Baliga, "New Materials Enhance Memory Performance", Semiconductor International, November 1999, pgs. 1-8.					
	AQ		Advances in Ultrathin Oxides and Oxynitrides I, Materials Research Society Symposium Proceedings Series, Vol. 567,, April 5, 1999, 2 pages.					
	AR		K.S. Tang, W.S. Lau, and G.S. Samudra, "Trends in Dram Dielectrics", IEEE Circuits & Devices, Vol. 13, No. 3, May 1997, pgs. 27-34					
EXAMINER		<i>John B. Phoy</i>			DATE CONSIDERED			8/22/2004
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-2496		Priority SERIAL NO. 09/943,137		
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	AM							
	AN							
	AO							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
<div style="font-size: 2em; font-family: cursive;">KBD</div> <div style="font-size: 2em; font-family: cursive;">↓</div>	AP		D.W. Hess, "Plasma-assisted oxidation, anodization, and nitridation of silicon", IBM Journal of Research & Development, Vol. 43, No. 1/2, Plasma processing, 22 pages.					
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	AR		Ting, Chen, Liu, "Structural evolution and Optical properties of TiO ₂ thin films prepared by thermal oxidation of sputtered Ti films", Journal of Applied Physics, Vol. 88, Number 9, 15 October 2000, pgs.4628-4633.					
EXAMINER		<div style="font-size: 1.5em; font-family: cursive;">John B. Dwyer</div>			DATE CONSIDERED			<div style="font-size: 1.5em; font-family: cursive;">8/22/2004</div>
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FOREIGN PATENT DOCUMENTS							
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							Yes No
	AK						
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	AM						
	AN						
	AO						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AP		O. Kubaschewski, B.E. Hopkins, "Oxidation of Metals and Alloys", Butterworths, London, Second Edition, 1962, pgs. 36-37 and 70-73.				
	AQ		F.P. Fehlner, "Low-Temperature Oxidation", Monograph published by Electrochemical Society, Pennington, New Jersey, 1983, pgs.31-35.				
	AR		Richard A. Swalin, "Thermodynamics of Solids" Second Edition, Chpt 5, John Wiley & Sons, 1972, pgs. 112-115.				
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